

## Refine Search

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### Search Results -

Terms	Documents
4226164.pn.	4

Database:

US Pre-Grant Publication Full-Text Database  
 US Patents Full-Text Database  
 US OCR Full-Text Database  
 EPO Abstracts Database  
 JPO Abstracts Database  
 Derwent World Patents Index  
 IBM Technical Disclosure Bulletins

Search:

5558717 . pn.



Refine Search

Recall Text

Clear

Interrupt

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### Search History

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DATE: Tuesday, August 16, 2005    [Printable Copy](#)    [Create Case](#)

**Set Name Query**

side by side

**Hit Count Set Name**

result set

*DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ*

<u>L14</u>	4226164.pn.	4	<u>L14</u>
<u>L13</u>	3689110.pn.	1	<u>L13</u>
<u>L12</u>	5997649.pn.	2	<u>L12</u>
<u>L11</u>	5972114.pn.	2	<u>L11</u>
<u>L10</u>	5950925.pn.	2	<u>L10</u>
<u>L9</u>	5728223.pn.	2	<u>L9</u>
<u>L8</u>	L1 and (CVD same diffus\$ same (channel or passage) same stage)	32	<u>L8</u>

*DB=USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ*

<u>L7</u>	L1 and ((multi or multiple or second)diffus\$ near3 stage)	3	<u>L7</u>
<u>L6</u>	L5	165	<u>L6</u>

*DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ*

<u>L5</u>	L1 and (diffus\$ near3 stage)	241	<u>L5</u>
<u>L4</u>	11 and lower diffusion stage	8	<u>L4</u>
<u>L3</u>	11 and second diffusion stage	0	<u>L3</u>

L2 L1 and (multi near3 stage near4 diffus\$)

13 L2

L1 CVD or chemical vapor deposition

189252 L1

END OF SEARCH HISTORY